In re Application of:

MITSUTOSHI HASEGAWA

Application No.: 09/966,595

Filed: October 1, 2001

For: METHOD OF MANUFACTURING ELECTRON-EMITTING DEVICE, ELECTRON SOURCE AND

IMAGE-FORMING APPARATUS

Docket No. 03500.011922.3

Examiner: M. Cleveland

Group Art Unit: 1762

Date: March 11, 2002

THE COMMISSIONER FOR PATENTS Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

| X | No additional fee is required.

The fee has been calculated as shown below

RECEIVED

TC 1700

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	* 4	MINUS	** 20	0	x \$9 \$18	0	
INDEP. CLAIMS	* ₅	MINUS	***	0	x \$42 \$84	0	
Fee for Mu	0						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						0	

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	°Verified Statement	claiming small	entity status is	enclosed,	if not filed	previously
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	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicant Registration No. 42,476
	Registration No. Luci

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
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PATENT APPLICATION

IN THE UNITED STATES PAT	TENT .	AND TRADEMARK	COFFICE	#/
In re Application of:)	Examiner: M. Clev	veland	- Heldy
MITSUTOSHI HASEGAWA		Group Art Unit: 1		3/28/00
Application No.: 09/966,595)	1		, ,
Filed: October 1, 2001)		A.	
For: METHOD OF MANUFACTURING ELECTRON-EMITTING DEVICE, ELECTRON SOURCE AND IMAGE-) :		MAR	CEIVED
FORMING APPARATUS	:	March 11, 2002	'C 7	700

Commissioner for Patents Washington, D.C. 20231

REQUEST FOR APPROVAL TO MAKE DRAWING CHANGES

Sir:

With the Examiner's approval, and at such time as a Notice of Allowance may issue, Applicant proposes to amend the drawings in the above-identified application as shown on the attached copies of Figs. 4A, 4B, 5, 6, 7, 9, 12, 13A, 13B, and 16.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on March 11, 2002.

(Date of Deposit)

FRANK A. DeLUCIA

of Attorney for Applicant)

March 11, 2002

Date of Signature

The proposed changes are indicated in red on the attached duplicate copies of the pertinent figures as filed.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,

Attorney for Applicant

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New York, New York 10112-3801
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